

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Confirmation No: 2500
Koichiro TANAKA et al.)	Group Art Unit: 3742
Serial No. 10/586,048)	Examiner: Sang Y. Paik
Filed: July 14, 2006)	
For: LASER IRRADIATION APPARATUS)	
AND LASER IRRADIATION METHOD)	
)	

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated April 1, 2009, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.